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PTO/SB/21 (08-00)

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Total Number of Pages in This Submission

Application Number	09/632,425
Filing Date	August 4, 2000
First Named Inventor	Geiger, Fabrice
Group Art Unit	2829
Examiner Name	Lisa A. Kilday

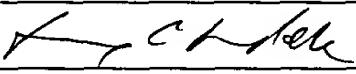
Attorney Docket Number

A3024/T28300

ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form	<input type="checkbox"/> Assignment Papers <i>(for an Application)</i>	<input type="checkbox"/> After Allowance Communication to Group
<input type="checkbox"/> Fee Attached	<input type="checkbox"/> Drawing(s)	<input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences
<input checked="" type="checkbox"/> Amendment / Reply	<input type="checkbox"/> Licensing-related Papers	<input type="checkbox"/> Appeal Communication to Group <i>(Appeal Notice, Brief, Reply Brief)</i>
<input checked="" type="checkbox"/> After Final	<input type="checkbox"/> Petition	<input type="checkbox"/> Proprietary Information
<input type="checkbox"/> Affidavits/declaration(s)	<input type="checkbox"/> Petition to Convert to a Provisional Application	<input type="checkbox"/> Status Letter
<input type="checkbox"/> Extension of Time Request	<input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address	<input checked="" type="checkbox"/> Other Enclosure(s) <i>(please identify below):</i>
<input type="checkbox"/> Express Abandonment Request	<input type="checkbox"/> Terminal Disclaimer	Two Return Postcards
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<input type="checkbox"/> Response to Missing Parts/ Incomplete Application		
<input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53		
	Remarks	The Commissioner is authorized to charge any additional fees to Deposit Account 20-1430.

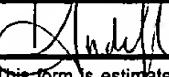
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm and Individual name	Townsend and Townsend and Crew LLP	Reg. No. 41,405
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Date	2-11-03	

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By Andrea



AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE -
EXAMINING GROUP 2829

PATENT
Attorney Docket No.: A3024/T28300
TTC Ref. No.: 16301-028300

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Fabrice Geiger et al.

Application No.: 09/632,425

Filed: August 4, 2000

For: PROCESS FOR DEPOSITING A
POROUS, LOW DIELECTRIC
CONSTANT SILICON OXIDE FILM

Examiner: Lisa A. Kilday

AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE EXAMINING
GROUP 2829

Box AF

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Final Office Action mailed December 11, 2002, please amend this application as follows:

IN THE SPECIFICATION:

Page 17, TABLE 2, please change "500 Å/min" to --5500 Å/min--.

Page 17, please delete footnotes 1 and 2.

Page 17, lines 2-7, please amend the paragraph as follows:

From Table 2, if the underlayer is thermal oxide then the deposition rate is lower, the wet etch rate is significantly higher, the surface roughness worse, and the stress hysteresis, in a room temperature to 360°C heat cycle, is higher than an underlayer

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